



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Image

1753

In re the Application of

Kazunori ANAZAWA

Application No.: 10/080,701

Filed: February 25, 2002

Docket No.: 112055

For: PRODUCING APPARATUS AND PRODUCING METHOD FOR MANUFACTURING
CARBON STRUCTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

P.O. Box 1450

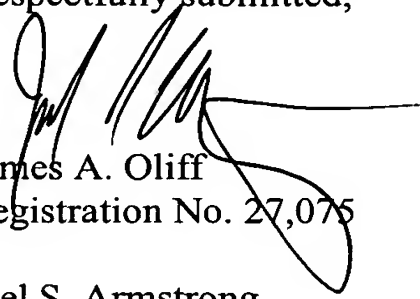
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references 2-4 and 6-8 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 3. English-language Abstracts of the non-English language references 2-6 are attached hereto.
- ☒ 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 2-3 and 5-6.
- ☒ 5. A concise explanation of the relevance of the non-English language references 2, 4, 6 appears in the Appendix attached hereto.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Joel S. Armstrong
Registration No. 36,430

JAO:JSA/smk

Date: December 30, 2003

OLIFF & BERRIDGE, PLC

P.O. Box 19928

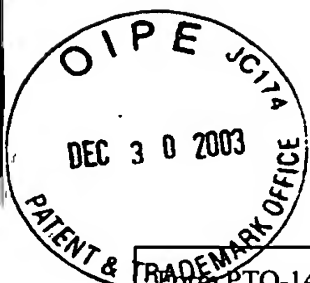
Alexandria, Virginia 22320

Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION

Please grant any extension
necessary for entry;

Charge any fee due to our
Deposit Account No. 15-0461

Sheet 1 of 1

PTO-1449 (REV. 8-83) US Dept. of Commerce PATENT & TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY DOCKET NO. 112055	APPLICATION NO. 10/080,701
	APPLICANT Kazunori ANAZAWA	
	FILING DATE February 25, 2002	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1	5,482,601	1/9/1996	OHSHIMA et al.		

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	2	JP A 08-48510 w/ Abst & Trans	2/20/1996	Japan		
	3	JP A 2002-69756 w/ Abst & Trans	3/8/2002	Japan		
	4	JP A 58-185767 w/ Abstract	10/29/1983	Japan		
	5	JP A 07-216660 w/ Abst & Trans	8/15/1995	Japan		
	6	JP A 2002-356316 w/ Abst & Trans	12/13/2002	Japan		
	7	EP 0 665 187 A1	8/2/1995	Europe		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	8	Kazunori ANAZAWA et al., "High-purity carbon nanotubes synthesis method by an arc discharging in magnetic field", Applied Physics Letters, July 22, 2002, Vol. 81. Num 4, Pgs. 739-741

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: December 30, 2003